Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/634,055	YU, JEN-CHEN
Examiner	Art Unit
Michael A. Friedhofer	2832

SEARCHED				
Class	Subclass	Date	Examiner	
200	4,5r,6a,17r ,18,406, 332,335	8/23/2005	MAF	
345	157,161	8/23/2005	MAF	
463	36-38	8/23/2005	MAF	
341	20	8/23/2005	MAF	
273	148r	8/23/2005	MAF	
74	471	8/23/2005	MAF	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
200	4,5r,6a	8/23/2005	MAF	
200	17r,18	8/23/2005	MAF	
200	406,332	8/23/2005	MAF	
200	/335	8/23/2005	MAF	

	DATE	EXMR
interference search: see search history	8/23/2005	MAF
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